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Paper No. 13

Date : March 12, 2001
TO : Director, Office of Publication and Dissemination
FROM : Office of the Deputy Commissioner
for Patent Examination Policy
SUBJECT : Withdrawal from Issue of
Applicant(s) : Shigekazu Kato et al
Application No. : 09/614,764
Filed : July 12, 2000

The above-identified application has been assigned Patent No. 6,205,678 and an issue date of March 27, 2001.

It is hereby directed that this application be withdrawn from issue at the request of the applicant.

Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of March 27, 2001:

"All reference to Patent No. 6,205,678 to Shigekazu Kato et al of Japan for VACUUM PROCESSING APPARATUS AND OPERATING METHOD THEREFOR appearing in the Official Gazette of March 27, 2001 should be deleted since no patent was granted."

Karen Creasy

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